

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Hajime YAMAMOTO et al.**

Art Unit: **1795**

Application Number: **10/647,247**

Examiner: **Daborah Chacko Davis**

Filed: **August 26, 2003**

Confirmation Number: **1773**

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, AND
METHOD OF FORMING RESIST PATTERN**

Attorney Docket Number: **031029**
Customer Number: **38834**

AMENDMENT UNDER 37 C.F.R. §1.114

Mail Stop: RCE

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

April 9, 2009

Sir:

This Amendment is being filed concurrently with a Request for Continued Examination pursuant to 37 C.F.R. §1.114 and is also being filed in response to the Final Office Action dated December 11, 2008.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.